

120363-1

CLEAN VERSION OF THE CLAIMS: Please amend Claim 1 as follows, written in clean version:

1. (Amended) A method of forming an embossed substrate, comprising:

a¹ disposing a substrate between a platen and a magnetically impermeable stamper comprising a negative of a desired surface feature, wherein the stamper is affixed to a magnetically permeable block comprising an induction coil;

pressing the stamper and the substrate together;

passing an alternating electrical current through the induction coil to raise the temperature of the stamper above a softening temperature of a substrate surface; and

changing the alternating electrical current;

whereby the embossed substrate is formed,